IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Itorse application of: Isamu AKASAKI; Hiroshi AMANO; Satoshi KAMIYAMA, all of Aichi; Takanori YASUDA; Itorshiya MATSUDA, both of Kyoto; all of Japan Serial No: Not Assigned Filed: March 26, 2004 For: Semiconductor Apparatus, Method for Growing Nitride Semiconductor and Method for Producing Semiconductor Apparatus										
Mail Stop PATENT APPLICATION Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450										
Dear Sir: CORRESPONDENCE ADDRESS: ☐ Customer Number ☐ 000026021 ☐ 00002602										
Transmitted herewith for filing is the patent application identified above. 13										
⊠ F	eturn postcard is enclosed.	CAI	LCULA	TION OF FEES						
	ITEM	TOTAL NO. OF CLAIMS		NO. OF CLAIMS OVER BASE	LG/S \$ ENTIT	SM Y FEE	\$ AMOUNT	\$ FEE		
А	TOTAL CLAIMS FE□E	32	-20	12	LG=\$18 SM=\$9	\$18	216.00			
В	INDEPENDENT CLAIMS FEE*	6	-3	4	LG=\$86 SM=\$43	\$86	344.00			
С	SUBTOTAL - ADDITIONAL CLAIM	S FEE (ADD FINAL COL	UMN IN	LINES A + B)		•	'	560.00		
D	MULTIPLE-DEPENDENT CLAIMS	FEE					TY FEE = \$290	\$ 0		
E	BASIC FEE SMALL ENTITY FEE = \$145 LARGE ENTITY FEE = \$770 SMALL ENTITY FEE = \$385							\$ 770.00		
F	TOTAL FILING FEE (ADD TOTALS	FOR LINES C, D, AND	E)		0141	ALL LINII	11122 - \$500	\$ 1330.00		
G							\$ 40			
<u></u>	*LIST INDEPENDENT CLAIMS 1									
 □ Please charge my Deposit Account No. 50-1314 the amount of \$_0 A copy of this letter is enclosed. □ A check in the amount of \$_0_ to cover the filing fee is enclosed. □ A check in the amount of \$_40.00_ to cover Assignment Recordation fee is enclosed. □ The Commissioner is hereby authorized to charge any deficiency for the following fees associated with this communication or credit any overpayment to Deposit Account No. 50-1314. A copy of this sheet is enclosed. □ Any additional filing fees required under 37 C.F.R. 1.16 □ Any patent application processing fees under 37 C.F.R. 1.17 										
Date:	March 26, 2004			Respectfully sub HOGAN & HAP By:						
500 South Grand Avenue, Suite 1900					No 41,2 Applicant					

PATENT Attorney Docket No: 81716.0122

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

)	In	re	app	lication	of:

Art Unit:

Not Assigned

AKASAKI, et al.

Examiner: Not Assigned

Serial No: Not Assigned

Filed: March 26, 2004

Semiconductor Apparatus, Method for Growing Nitride

Semiconductor and Method for Producing Semiconductor

Apparatus

CERTIFICATE OF MAILING VIA U.S. EXPRESS MAIL "Express Mail" Mailing Label No. EV 325 215 076 US

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Dear Sir:

I hereby certify that

- two copies of a letter of transmittal
- patent application (63 page(s) of specification; 32 claim(s); 1 page(s) of abstract
- \boxtimes 13 sheet(s) of formal drawings
- certified copies of <u>Japanese</u> Patent Application No. <u>2003-085941</u>; <u>2003-085942</u>; and <u>2003-085955</u> filed <u>March 26, 2003</u> and Application Nos. <u>2003-146965</u> filed <u>May</u> 23, 2003; and 2003-151697 filed May 28, 3003 from which priority is claimed under 35 U.S.C. § 119 are enclosed.
- return postcard

are being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service with sufficient postage under 37 C.F.R. § 1.10 on the date indicated above and are addressed to:

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Signature